OIPE JC181 AUG 29 2003 PATENT & TRADEMARK OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Suzuki, et al.

Serial No.: 10/004,489

Confirmation No.: 9428

Filed: October 23, 2001

For: Method of Forming Film, Method of Manufacturing Semiconductor Device and Film Forming Apparatus

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§ Group Art Unit: 2818
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§ Examiner: Renee R. Berry
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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING
37 CFR 1.8
I hereby certify that this correspondence is being deposited on August 27, 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

8/27/03
Date

Signature

RESPONSE TO OFFICE ACTION DATED JULY 9, 2003

In response to the Office Action dated July 9, 2003, having a shortened statutory period for response set to expire on October 9, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/3819/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks/Arguments** begin on page 5 of this paper.